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Examiner

LEE, JAE WOO
Art Unit

Applicant(s)/Patent under Reexamination

Dennis H. Pedder

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	SEARCHED		
Class	Subclass	Date	Examiner
296	97.7 97.8		
160	370.21		
UPDATED	ABOVE	10/26/2006	DHP

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
296	97.8		
296	97.7	10/26/2006	DHP

SEARCH NO (INCLUDING SEARCH	TES STRATEGY)
	DATE	EXMR
INTERFERENCE SEARCH-SEE SEARCH HISTORY	10/26/2006	DHP
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